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RANSMITTA	Application Number		10/792,038			
UL 0 2 2004 5 FORM	UL 0 2 2004 5 FORM			March 3, 2004		
(to be used for all correspondence after i	initial filing)	First Named Inventor		Melissa K. Rath, et al.		
TRADE		Group Art Unit		1756		
		Examiner Name		ТВА		
Total Number of Pages in This Sub	Total Number of Pages in This Submission			ATMI-668		
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Fee Transmittal Form	Assignm (for an A	nent Papers Application)		After Allowance Communication to Group		
Fee Attached	Drawing	g(s) .		Appeal Communication to Board of Appeals and Interferences		
Amendment / Reply	Licensin	ng-related Papers		Appeal Communication to Group (Appeal Notice, Brief, Reply Brief)		
After Final	Petition			Proprietary Information		
· Affidavits/declaration(s)		to Convert to a nal Application		Status Letter		
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Response to Missing Parts/ Incomplete Application	Remarks					
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Firm William F. Ryann, R						
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bate 6/30/04						
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Date

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N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Melissa K. Rath, et al.

Group Art Unit: 1756

U.S. Application No.: 10/792,038

Examiner: TBA

Filed: March 3, 2004

Title: COMPOSITION AND PROCESS FOR POST-ETCH REMOVAL OF PHOTORESIST

AND/OR SACRIFICIAL ANTI-REFLECTIVE MATERIAL DEPOSITED ON A

SUBSTRATE

CERTIFICATE OF MAILING

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on the date indicated below and is addressed to the Commissioner of Patents, P.O. Box 1450, Alexandria, VA

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

■ 1. This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required in accordance with 37 CFR § 1.56 and § 1.97(b).

□ 2.	This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.				
	□ a.	I hereby certify that each item of information contained in this Information Disclosure Statement was the first citation of such item by a foreign patent office in a counterpart foreign application, which occurred no more than three months prior to filing the Information Disclosure Statement. 37 C.F.R. §1.97(e)(1).			
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	□ c.	Attached is our check no in the amount of \$180 in payment of the fee under 37 C.F.R. §1.17(p). Please credit or debit Deposit Account No. 50-0860 as needed to ensure consideration of the disclosed information. Two duplicate copies of this paper are attached.			
□ 3.	U.S. fi but be: Disclo \$130.0 Depos	information Disclosure Statement is being filed more than three months after the dling date and after the mailing date of a Final Rejection or Notice of Allowance, fore payment of the Issue Fee. Applicant(s) hereby petition(s) that the Information sure Statement be considered. Attached is our check no in the amount of 0 in payment of the petition fee under 37 C.F.R. §1.17(i)(1). Please credit or debit it Account No as needed to ensure consideration of the disclosed information. uplicate copies of this paper are attached.			
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□ 4.	(other)	:			

Applicant does not believe that any additional fee is due in connection with the foregoing. However, any deficiencies may be charged to the deposit account 50-0860.

Respectfully submitted,

William F. Ryann

Registration No. 44,313 Attorney for Applicant

Date: (q - 30 - 0)Advanced Technology Materials, Inc. 7 Commerce Drive
Danbury, CT 06810
Attorney Ref: ATMI-668

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EXAMINER		PATENT	0.5.	FATENT DOCUMENTS	-		FILING	DATE
INITIAL		NUMBER	ISSUE DATE	NAME	CLASS	SUBCLASS		
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	DOCUMENT PUBLICATION NUMBER DATE COUNTRY CL		CLASS	SUBCLAS	TRANSLATION YES NO			
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